



3-1-06

IFW

Attorney Docket No. 5308-279

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Sei-Hyung Ryu                                  Group Art Unit: 2818  
Serial No.: 10/698,170                                  Confirmation No. 2502  
Filed: October 30, 2003                                  Examiner: Long K. Tran  
For: **VERTICAL JFET LIMITED SILICON CARBIDE POWER METAL-OXIDE  
SEMICONDUCTOR FIELD EFFECT TRANSISTORS**

Date: February 28, 2006

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO ELECTION REQUIREMENT**

Sir:

Applicant provides the present Response to Election Requirement to address the issues raised in the Action dated January 30, 2006.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 8 of this paper.